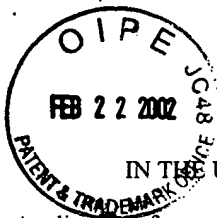


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Docket No.: 42390P6623

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of:

QING MA, ET AL.

Application No.: 09/374,502

Filed: August 13, 1999

For: **ISOLATION STRUCTURE CONFIGURATIONS
FOR MODIFYING STRESSES IN
SEMICONDUCTOR DEVICES**

Art Group: 2815

Examiner: J. Fenty

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3/12/02

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PETITION FOR EXTENSION OF TIME PURSUANT TO 37 C.F.R. § 1.136(a)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In accordance with 37 C.F. R. § 1.136(a), Applicants for the above-identified application respectfully Petition the Commissioner for a one (1) month month extension of time, extending the period for response to January 17, 2002, from the Final Office Action dated September 17, 2001. The petition filing fee of \$110.00 and the Response to Final Office Action are attached.

If it should be determined that a longer extension of time is required to prevent this application from being abandoned, please charge any additional fees to Deposit Account No. 02-2666. A copy of the Fee Transmittal is enclosed for deposit account charging purposes.

12/01/2002 DISPOSED: 1001, 1002, 1003, 1004

11/01/02

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: January 17, 2002

Paul A. Mendonsa, Reg. No. 42,879

12400 Wilshire Blvd., 7th Floor
Los Angeles, California 90025
Telephone: (503) 684-6200

I hereby certify that this correspondence is being deposited with United States Postal Service as First Class mail with sufficient postage in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on: January 17, 2002.

Deborah L. Higham

01-17-02
Date